

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : Paul D. Shirley

Serial No. : 10/773,968

Filed : February 6, 2004

Title : **DEVICE AND METHOD FOR FORMING IMPROVED RESIST LAYER**

Docket : MIO 0112 PA/40509.272

Examiner : Laura E. Edwards

Art Unit : 1792

Conf. No. : 7341

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

EFS Web Electronic Submission

July 30, 2008

Sir:

RESPONSE UNDER 37 CFR 1.116

This paper is being filed in response to the Office Action mailed on June 27, 2008.
Reconsideration of the present application is respectfully requested in light of the remarks below.